FlexTRAK[™]-S Plasma System

Features and Benefits

- Large-capacity plasma chamber, 9.6 liter, or twice the capacity of a standard FlexTRAK[™] plasma system, with high uniformity and short cycle times
- Easily integrates with a variety of process equipment, including wire bond, die attach, dispense, mold and marking equipment
- Slim structure requires minimal floor space. Service components are easily accessible from the front
- Flexible chamber configurations support direct, downstream and ion-free modes of plasma treatment
- Adjustable chamber kits and fixtures support the processing of a multitude of different substrates and products



Superior Plasma Process Quality and Uniformity

Specially designed for processing larger substrates, the FlexTRAK™-S platform meets the plasma treatment requirements of advanced semiconductor and electronic packaging. It delivers uniform treatment and efficiency for a wide range of plasma applications. A higher power RF generator and improved vacuum conductance allows the FlexTRAK-S to perform equivalent to the smaller FlexTRAK platform. The chamber architecture remains the same, although elongated to accommodate more substrates. The result is a seamless transition between plasma chambers as production demands more capacity.

High-Throughput Processing Capability

The FlexTRAK-S platform is a highly configurable, high-throughput plasma system. Its universal architecture accommodates a multitude of material handling configurations to support a wide assortment of variable-size form factors. Its chamber volume and proprietary process control enable unmatched short cycle times, while its slim structure minimizes floor space requirements.

The FlexTRAK-S platform handles a wide variety of product form factors, including boats, carriers, Jedec/Auer® boats, strips, and laminates. Depending on throughput and product form requirements, the system can be configured for magazine-to-magazine processing of single and multiple strips or lead frames and standalone for island-based production environments.

SMART Tune™ Management System

The FlexTRAK-S platform's SMART Tune management system provides closed-loop plasma control that optimizes the RF system and minimizes tuning time. The system automatically recycles to a plasma-ready state, compensating for changes in vacuum pressure, temperature and varied lot sizes. Maximum power to the chamber is achieved in seconds with a proprietary algorithm that constantly measures forward and reflective power inside the chamber.



Specifications: FlexTRAK™-S Plasma Systems

| Enclosure Dimensions | W x D x H – Footprint | 382W x 1210D x 1595H mm (2037H mm with light tower) 15W x 47.6D x 62.8H in. (80.2H in. with light tower) |
|-------------------------|--------------------------------------|--|
| | Net Weight | 315 kg (693 lbs) |
| | Equipment Clearance | Right, Left – 153 mm (6 in), Front, Back – 914 mm (36 in) |
| Chamber | Maximum Volume | 9.6 liters (585 in³) |
| Electrodes | Variable Electrode Configurations | Power-Ground, Ground-Power; Power-Power |
| | Working Area | 305W x 560D mm (12W x 22D in.) |
| RF Power | Standard Wattage | 600 W |
| | Optional Wattage | 1000 W |
| | Frequency | 13.56 MHz |
| Gas Control | Available Flow Volumes | 10, 25, 50, 100, 250 or 500 sccm |
| | Maximum Number of MFCs | 4 |
| Control & | Software Control | EPC with PC-Based Touch Screen Interface |
| Interface | Remote Interface | SMEMA, SECS/GEM |
| Vacuum Pump | Standard Dry Pump | 16 cfm |
| | Optional Wet Pump | 19.5 cfm |
| | Optional Purged Dry Pump | 16 cfm |
| | N2 Purged Pump Flow | 2 slm |
| Facilities | Power Supply | 220 VAC, 15A, 50/60 Hz, 1-Phase, 12 AWG, 3-Wire |
| | Process Gas Fitting Size & Type | 6.35 mm (0.25 in.) OD Swagelok Tube |
| | Process Gas Purity | Lab or Electronic Grade |
| | Process Gas Pressure | 0.69 bar (10 psig) min. to 1.03 bar (15 psig) max., regulated |
| | Purge Gas Fitting Size & Type | 6.35 mm (0.25 in.) OD Swagelok Tube |
| | Purge Gas Purity | Lab or Electronic Grade N2/CDA |
| | Purge Gas Pressure | 2 bar (30 psig) min. to 6.9 bar (100 psig) max., regulated |
| | Pneumatic Valves Fitting Size & Type | 6.35 mm (0.25 in.) OD Swagelok Tube |
| | Pneumatic Gas Purity | CDA, Oil Free, Dewpoint ≤7°C (45°F), Particulate Size <5 µm |
| | Pneumatic Gas Pressure | 3.45 bar (50 psig) min. to 6.89 bar (100 psig) max., regulated |
| | Exhaust | 25.4 mm (1 in.) OD Pipe Flange |
| Compliance | SEMI | S2/S8 (EH&S/Ergonomics) |
| | International | CE Marked |
| Ancillary Equipment | Gas Generators | Nitrogen, Hydrogen (Requires Additional Non-Optional Hardware) |
| | Facilities | Chiller, Scrubber |

For more information, speak with your local representative or contact your regional office.

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